

IN THE UNITED STATES PATENT AND TRADE MARK OFFICE

Our Ref.: MOR-4

In re Application of: :  
T. Shirafuji, et al :  
Serial No.: : International Application PCT /JP/2004/16606  
Filed: Concurrently herewith : Filed 2004  
For: FLUOROCARBON FILM AND  
METHOD FOR FORMING THE  
SAME


May 25, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313

INFORMATION DISCLOSURE STATEMENT

To comply with Rule 56, applicants are enclosing herewith 5 references that are related to the invention claimed in the above application.

Respectfully submitted,

  
Charles A. Muserlian, 19,683  
Hedman & Costigan  
1185 Avenue of the Americas  
New York, NY 10036  
(212) 302-8989

PTO/SB/08A (08-03)

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>		<b>Complete if Known</b>	
		Application Number	
		Filing Date	
		First Named Inventor	Tatsuru SHIRAFUJI
		Art Unit	
Examiner Name			
Sheet 2 of 2	Attorney Docket Number	MOR-4	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		KAZUO TAKAHASHI, et al, Structure and Pore Formation of Fluorocarbon Films Polymerized in Plasmas, V-4 2001 Dry Process International Symposium pages 181 to 186	
		Tatsuru SHIRAFUJU, et al PLAS COPOLYMERIZATION OF...INFRARED SPECTROSCOPY, JAPANESE JOURNAL OF APPLIED PHYSICS , VOL 43, NO. 5A, 2004, PP 2697-1703	

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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